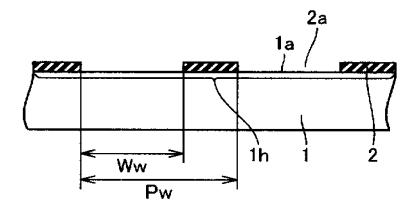
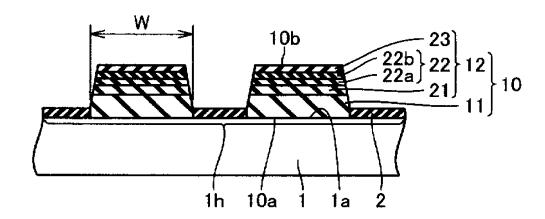
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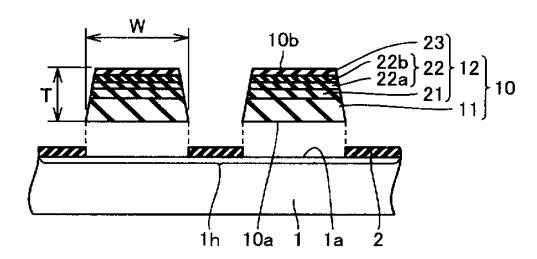
[図1A]



[図1B]

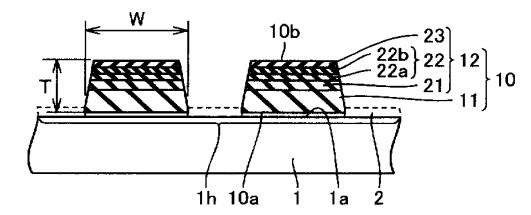


[図1C]

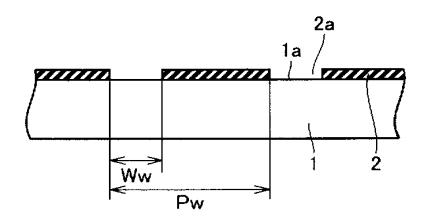


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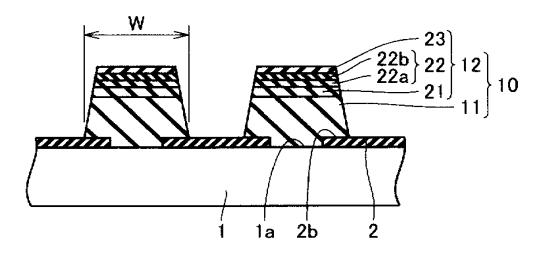
[図1D]



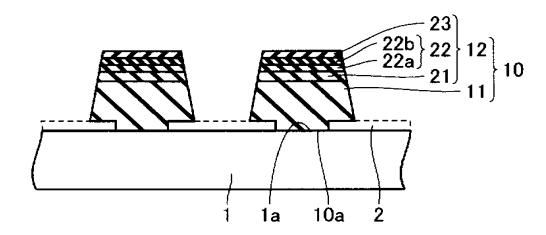
[図2A]



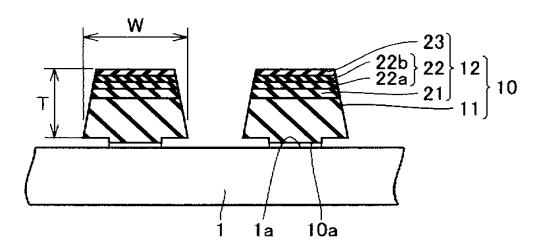
[図2B]



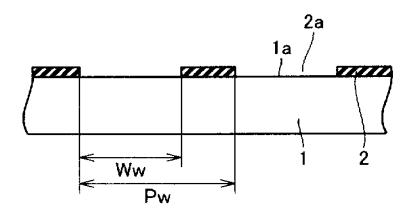
[図2C]



[図2D]

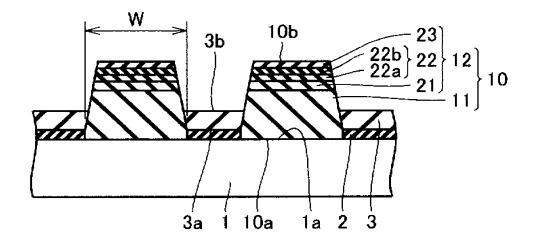


[図3A]

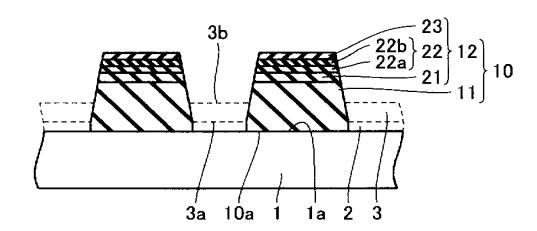


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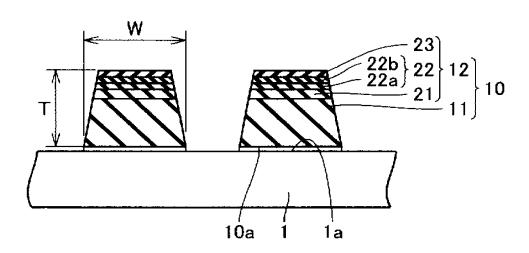
[図3B]



[図3C]

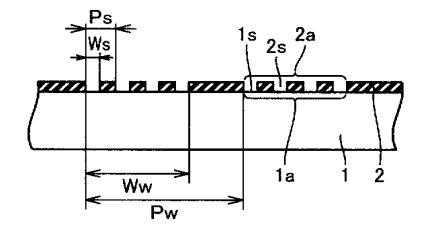


[図3D]

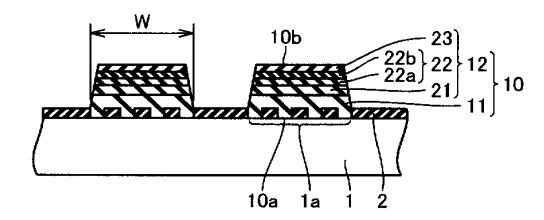


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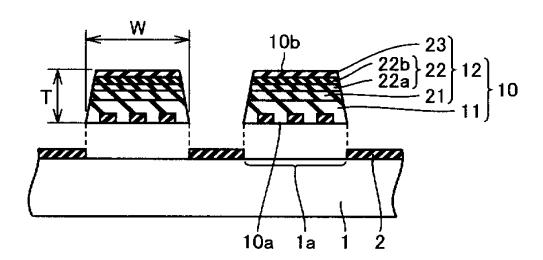
[図4A]



[図4B]



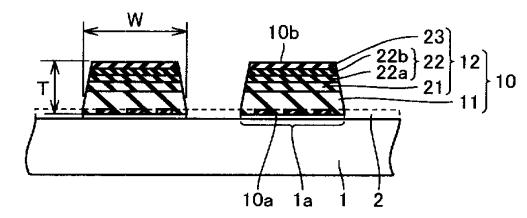
[図4C]



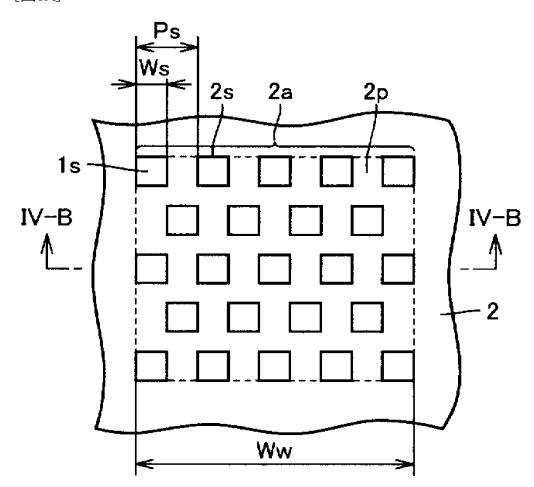
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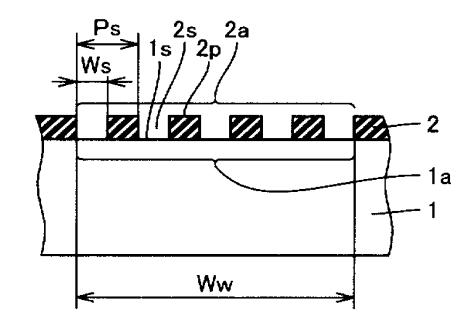
[図4D]



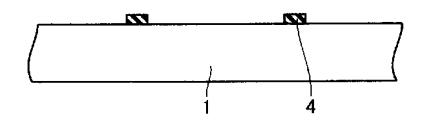
[図5A]



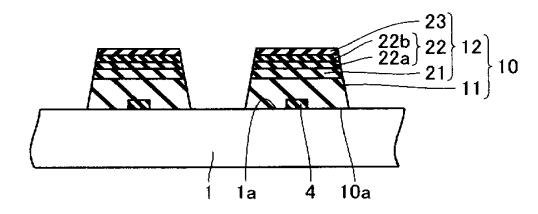
[図5B]



[図6A]

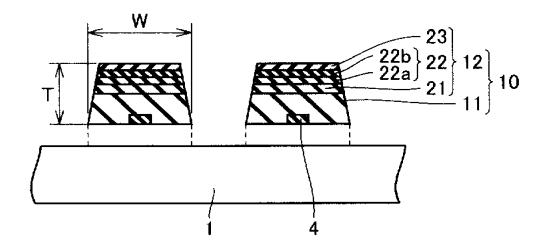


[図6B]

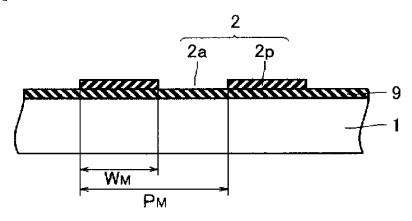


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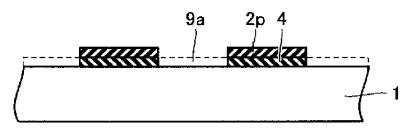
[図6C]



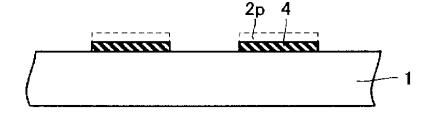
[図7A]



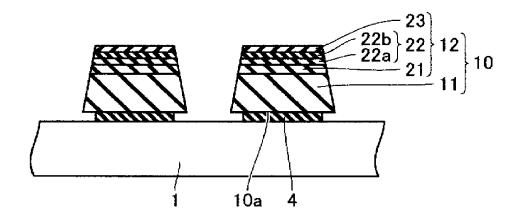
[図7B]



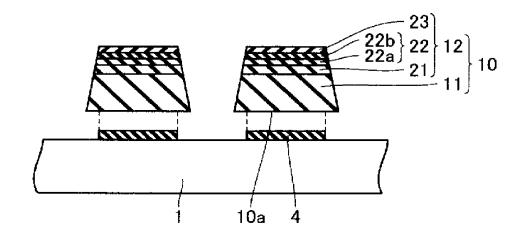
[図7C]



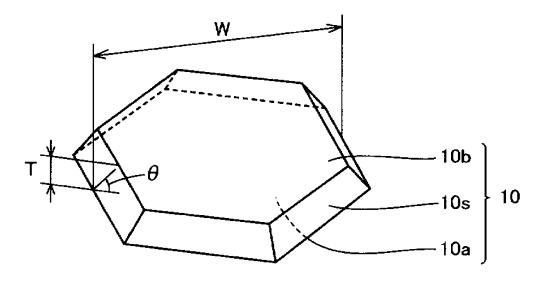
[図7D]



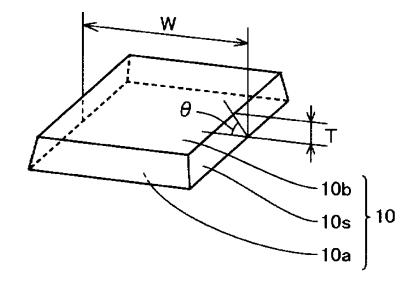
[図7E]



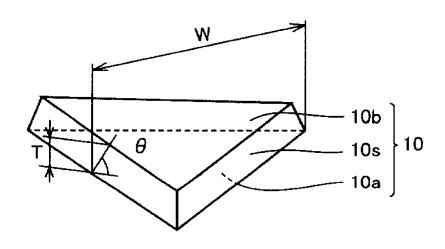
[図8A]



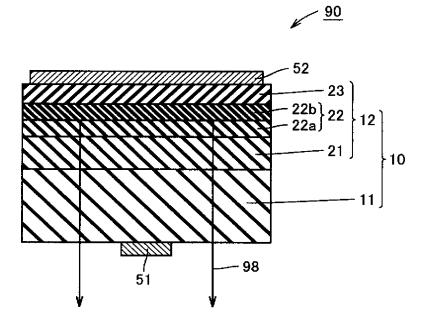
[図8B]



[図8C]

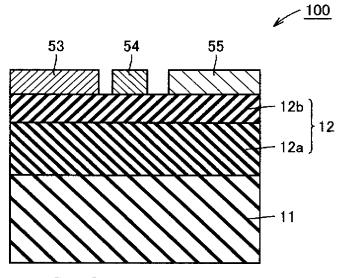


[図9]

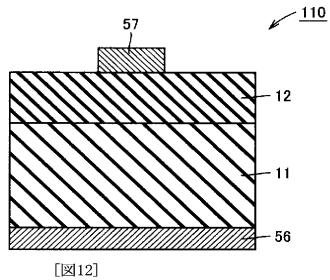


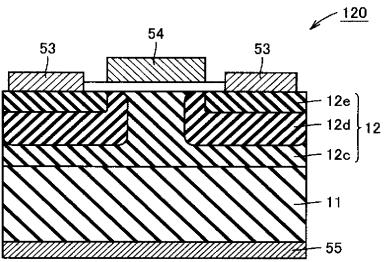
PCT/JP2005/008745



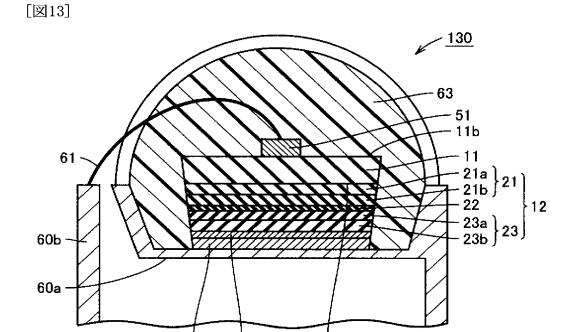


[図11]









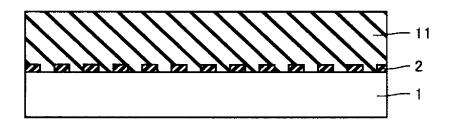
1Ìa

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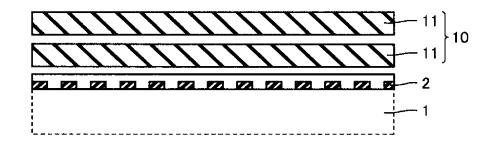
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[図14B]

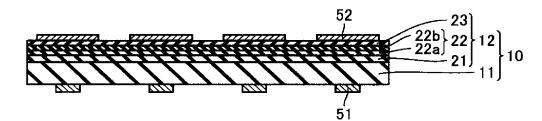
[図14A]



[図14C]



[図14D]



[図14E]

